Search Notes

| Application/Control I | No. Applicant(s)/Patent Reexamination | under |
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| 10/604,820 | CHI, CHAO-WEN | |
| Examiner | Art Unit | |
| Jeffrey Donels | 2837 | |

| Subclass | Date | Examiner |
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| SEARCH NOTES (INCLUDING SEARCH STRATEGY) | | | | |
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| BLS Text PLUS | 6/21/85 | Ap | | |
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